

10/024,850

Notice of References Cited

Application No.

08/951,819

Applicant

Shunpei Yamazaki et al.

Examiner

William David Coleman

Group Art Unit

2814

Page 1 of 1

U.S. PATENT DOCUMENTS

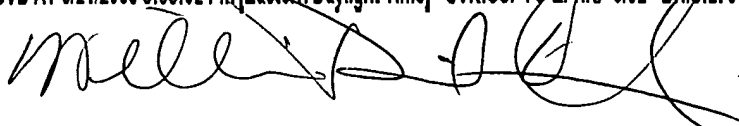
	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS
A	5,821,563	10/13/98	Yamazaki et al.	257	57
B	5,696,386	12/09/97	Yamazaki	257	57
C	5,569,936	10/29/96	Zhang et al.	257	57
D	5,614,732	03/25/97	Yamazaki	257	57
E	5,763,899	06/09/98	Yamazaki et al.	257	57
F	5,646,424	07/08/97	Zhang et al.	257	57
G	5,591,987	01/07/97	Yamazaki et al.	257	57
H	5,677,549	10/14/97	Takayama et al.	257	57
I	6,627,384	05/06/97	Teramoto et al.	257	57
J	5,717,224	02/10/98	Zhang	257	57
K					
L					
M					

FOREIGN PATENT DOCUMENTS

	DOCUMENT NO.	DATE	COUNTRY	NAME	CLASS	SUBCLASS
N						
O						
P						
Q						
R						
S						
T						

NON-PATENT DOCUMENTS

	DOCUMENT (Including Author, Title, Source, and Pertinent Pages)	DATE
U	Schoenfeld et al., "Crystallization of amorphous silicon by NiSi sub 2 precipitates", Thin Solid Films, pp 236-240, No. 261	12/95
V		
W		
X		



9/9/2005

10/024,850

Notice of References Cited				Application/Control No 08/951,819		Applicant(s)/Patent Under Reexamination YAMAZAKI ET AL.			
				Examiner W. David Coleman		Art Unit 2823		Page 1 of 1	
U.S. PATENT DOCUMENTS									
*		DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	DOCUMENT SOURCE **		
							APS	OTHER	
<input type="checkbox"/>	A	5,821,138	Oct. 1998	Yamazaki et al.	438	165	<input checked="" type="checkbox"/>	<input type="checkbox"/>	
<input type="checkbox"/>	B						<input type="checkbox"/>	<input type="checkbox"/>	
<input type="checkbox"/>	C						<input type="checkbox"/>	<input type="checkbox"/>	
<input type="checkbox"/>	D						<input type="checkbox"/>	<input type="checkbox"/>	
<input type="checkbox"/>	E						<input type="checkbox"/>	<input type="checkbox"/>	
<input type="checkbox"/>	F						<input type="checkbox"/>	<input type="checkbox"/>	
<input type="checkbox"/>	G						<input type="checkbox"/>	<input type="checkbox"/>	
<input type="checkbox"/>	H						<input type="checkbox"/>	<input type="checkbox"/>	
<input type="checkbox"/>	I						<input type="checkbox"/>	<input type="checkbox"/>	
<input type="checkbox"/>	J						<input type="checkbox"/>	<input type="checkbox"/>	
<input type="checkbox"/>	K						<input type="checkbox"/>	<input type="checkbox"/>	
<input type="checkbox"/>	L						<input type="checkbox"/>	<input type="checkbox"/>	
<input type="checkbox"/>	M						<input type="checkbox"/>	<input type="checkbox"/>	
FOREIGN PATENT DOCUMENTS									
*		DOCUMENT NO.	DATE	COUNTRY	NAME	CLASS	SUBCLASS	DOCUMENT SOURCE **	
								APS	OTHER
<input type="checkbox"/>	N							<input type="checkbox"/>	<input type="checkbox"/>
<input type="checkbox"/>	O							<input type="checkbox"/>	<input type="checkbox"/>
<input type="checkbox"/>	P							<input type="checkbox"/>	<input type="checkbox"/>
<input type="checkbox"/>	Q							<input type="checkbox"/>	<input type="checkbox"/>
<input type="checkbox"/>	R							<input type="checkbox"/>	<input type="checkbox"/>
<input type="checkbox"/>	S							<input type="checkbox"/>	<input type="checkbox"/>
<input type="checkbox"/>	T							<input type="checkbox"/>	<input type="checkbox"/>
NON-PATENT DOCUMENTS									
*		DOCUMENT (Including Author, Title Date, Source, and Pertinent Pages)						DOCUMENT SOURCE **	
								APS	OTHER
<input type="checkbox"/>	U							<input type="checkbox"/>	<input type="checkbox"/>
<input type="checkbox"/>	V							<input type="checkbox"/>	<input type="checkbox"/>
<input type="checkbox"/>	W							<input type="checkbox"/>	<input type="checkbox"/>
<input type="checkbox"/>	X							<input type="checkbox"/>	<input type="checkbox"/>

*A copy of this reference is not being furnished with this Office action. (See Manual of Patent Examining Procedure, Section 707.05(a).)

**APS encompasses any electronic search i.e. text, image, and Commercial Databases.

U.S. Patent and Trademark Office

PTO-892 (Rev. 03-98)

Notice of References Cited

Part of Paper No. 17

